L Number	Hits	Search Text	DB	Time stamp
1	350		USPAT;	2004/07/08 13:42
			US-PGPUB	
2	159	((438/704).CCLS.) and silicon with ((oxide dioxide) and	USPAT;	2004/07/08 13:43
		nitride)	US-PGPUB	
3	80	(((438/704).CCLS.) and silicon with ((oxide dioxide) and	USPAT;	2004/07/08 13:44
		nitride)) and (oxide dioxide) with (dry plasma anisotropic)	US-PGPUB	
		with (etch\$4)		
4	14	((((438/704).CCLS.) and silicon with ((oxide dioxide) and	USPAT;	2004/07/08 13:44
		nitride)) and (oxide dioxide) with (dry plasma anisotropic)	US-PGPUB	
		with (etch\$4)) and (nitride) with (wet with etch\$4)		